

## Message from the Editor-in-Chief

This article has been downloaded from IOPscience. Please scroll down to see the full text article.

2004 Plasma Sources Sci. Technol. 13

(<http://iopscience.iop.org/0963-0252/13/4/E01>)

View [the table of contents for this issue](#), or go to the [journal homepage](#) for more

Download details:

IP Address: 38.107.179.214

The article was downloaded on 16/02/2012 at 06:12

Please note that [terms and conditions apply](#).

## EDITORIAL

# *Message from the Editor-in-Chief*

**Noah Hershkowitz**  
*Editor-in-Chief, Plasma  
Sources Science and  
Technology*

2004 has been a successful year for PSST—we have received an increase in the number of articles submitted to the journal, and the growing popularity of the journal is also shown by significant increases in the electronic access and download figures.

We would like to thank all our authors and referees for their continued support of the journal, with a special thank-you to the referees for all their time spent reviewing articles on our behalf; their advice and help are always greatly appreciated.

Our aims for 2005 include introducing new software to enable both myself and the journal's publishing team to continue to reduce processing times, continuing to work to ensure that the scope and coverage of the journal meets the needs of the community, and maintaining the high quality standards of the journal. We would also like to work towards increasing the number of review articles in the journal. If you consider that a review in your topic of specialization would be timely, please get in touch!

We look forward to working with you to achieve these aims and I would like to wish you all success in 2005.

### **Message from the Publishers**

We would like to add our thanks to the authors and referees of *Plasma Sources Science and Technology* for their support of the journal and for all the helpful feedback we have received over the year at conferences and in other correspondence.

We would also like to take this opportunity to congratulate Professor Hershkowitz on being awarded both the **James Clerk Maxwell Prize of the APS Division of Plasma Physics** (along with Dr Valery Godyak of Osram Sylvania) and the **Plasma Prize of the Plasma Science and Technology Division of the American Vacuum Society**.

We offer our sincere thanks to Professor Hershkowitz for his tireless work throughout the year running the peer review for *Plasma Sources Science and Technology*.

Best wishes for 2005 from the PSST Editorial team:

Nicola Gulley, Group Publisher  
Beatrice Purser-Hallard, Publisher  
Sarah Towell, Publishing Administrator  
Adrian Corrigan, Production Editor